

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Michael E. Mack
Application Serial No.: 10/667,006
Filed: September 19, 2003
Title: SYSTEM FOR AND METHOD OF GAS CLUSTER ION BEAM PROCESSING
Attorney Docket: 11460-127

Confirm. No.: 9136
Group Art Unit: 1753
Examiner: McDonald, Rodney Glenn

Burns & Levinson LLP
125 Summer Street
Boston, MA 02110
(617) 345-3000

To: Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE C

Dear Sir:

This filing is in response to the Official Action dated August 9, 2007 in the above-identified patent application, the response time for which Official Action was set at three months.

Amendments to the claims begin on **page 2** of this paper.

Remarks begin on **page 10** of this paper.